

Application/Control No.	Applicant(s)/Patent under Reexamination	
09/555,255	HIGASHI ET AL	·•
Examiner	Art Unit	
MICHAEL L. SHIPPEN	1621	

					
	SEARCHED				
Class	Subclass	Date	Examiner		
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INT	INTERFERENCE SEARCHED		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
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